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(Revised 07/2007)

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
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**Complete if Known**

Application Number	10/572,764
Filing Date	May 16, 2007
First Named Inventor	Joseph M. DeSimone
Art Unit	1792
Examiner Name	Lightfoot, Elena Tsoy

Attorney Docket Number 035052/338792

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Examiner Initials*	Cite No.	Document Number Number - Kind Code (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages of Relevant Figures Appear
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Attorney Docket Number	035052/338792

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Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	English Language Translation Attached
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